

Electronic Acknowledgement Receipt

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Application Number:	10519475
International Application Number:	
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Title of Invention:	Plasma processing system and its substrate processing process, plasma enhanced chemical vapor deposition system and its film deposition process
First Named Inventor/Applicant Name:	Keisuke Kawamura
Customer Number:	22850
Filer:	Marvin Jay Spivak/shericka young
Filer Authorized By:	Marvin Jay Spivak
Attorney Docket Number:	263788US2PCT
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
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1		263788USAMDT.pdf	521028 617c342f471b6c094772473fd6d87125b89a2123	yes	14
	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Miscellaneous Incoming Letter		1	1	
	Extension of Time		2	2	
	Amendment After Final		3	3	
	Claims		4	9	
	Applicant Arguments/Remarks Made in an Amendment		10	14	
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	8236 3ded0875d8ba1bf3c6065718216c9979327ac63a	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			529264		
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